

Effects of Finite Probe Size on Self-Affine Roughness Measurements

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The roughness of fracture surfaces exhibits self-affinity for a wide variety of materials and loading conditions. The universality and the range of scales over which this regime extends are still debated. The topography of these surfaces is however often investigated with a finite contact probe. In this case, we show that the correlation function of the roughness can only be measured down to a length scale Δx_c which depends on the probe size R , the Hurst exponent ζ of the surface and its topothesy l , and exhibits spurious behavior at smaller scales. First, we derive the dependence of Δx_c on these parameters from a simple scaling argument. Then, we verify this dependence numerically. Finally, we establish the relevance of this analysis from AFM measurements on an experimental glass fracture surface and provide a metrological procedure for roughness measurements.

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Fractography has long been a fruitful method to decipher the microscopic mechanisms of fracture in heterogeneous materials (see, e.g., [1,2] for reviews). Since an early paper by Mandelbrot *et al.* [3], a growing interest has developed in the understanding of the fractality of crack surfaces. One of the most prominent features of these surfaces is the self-affine structure of their roughness in various materials, ranging from ductile metallic alloys to brittle mortars or glasses [4–11]. A proper understanding and experimental characterization of this feature has both applied and fundamental stakes. On the one hand, it has recently led to a method to extract the direction of crack propagation from the analysis of roughness, which is of high practical importance [12]. On the other hand, the possible universality underlying this critical-like behavior remains to be assessed [13], together with the physical origin of the intrinsic cutoffs in the self-affine regimes [8,12]. These scaling properties have motivated the development of numerous models [14–20].

Recent advances in scanning probe microscopy (SPM), especially the development of atomic force microscopy (AFM), have provided large amounts of experimental data drawing a rather complicated picture of the situation: the reported exponents depend on the direction of analysis, the material and the resolution. Furthermore, the characteristic length scale of the self-affine regimes, or *topothesy*, is rarely reported or unphysical. This discrepancy in the reported exponents can originate from the existence of several universality classes and actual differences in the underlying physical mechanisms. However, it might also partly result from experimental biases. The list of possible biases is long and instrument dependent: i.e., environment noise, feedback loops, biases in the estimators [16], etc. Here, we focus on the subtle bias induced by the nonlinear smoothing effect of the finite-size contact probe used in topography measurements of self-affine surfaces [21].

In order to quantitatively estimate this bias, we investigate the consequences of using model probes of various sizes and shapes on ideal self-affine surfaces. As SPM topography measurements usually proceed line by line, we will study the one-dimensional problem of probing a self-affine profile $h(x)$ with a rigid tip defined by $f_R^{[\gamma]}(x) \equiv \frac{|x|^\gamma}{2R^{\gamma-1}}$, where R is the characteristic size of the apex and γ a shape parameter ($\gamma \geq 2$). This choice of shape is motivated by the possible flattening of real tips during scans [22]. The roughness features of the profile h are extracted from the height-height correlation function defined as

$$\Delta h(\Delta x) \equiv \sqrt{\langle [h(x + \Delta x) - h(x)]^2 \rangle_x}. \quad (1)$$

The profile $h(x)$ is self-affine if it is invariant under the transformation

$$x \rightarrow \lambda x \quad h \rightarrow \lambda^\zeta h \quad (2)$$

where ζ is the roughness or Hurst exponent. It follows that there is a physical length scale l , called the *topothesy*, for which the local slope of the profile becomes one. It verifies

$$\frac{\Delta h}{l} = \left(\frac{\Delta x}{l}\right)^\zeta \quad \text{i.e.,} \quad \Delta h = \Delta x^\zeta l^{1-\zeta}. \quad (3)$$

Physically, this parameter provides information about the amplitude of the roughness. In particular, it follows from Eq. (3) that vertically dilating the profile affects the topothesy as

$$h \rightarrow \mu h \quad l \rightarrow \mu^{1/(1-\zeta)} l. \quad (4)$$

Measuring such a profile with a finite-size SPM tip amounts to finding the height, $\tilde{h}(x)$ of the apex as the tip first touches the surface when approached from above, for

each value of x , as depicted in Fig. 1. This occurs at some position x_0 such that

$$\tilde{h}(x) \equiv \mathcal{S}_R[h](x) \equiv \max_{x'} [h(x') - g_R(x - x')] \quad (5)$$

where $g_R(x)$ describes the shape of the tip, R its size, and \mathcal{S}_R is a smoothing operator acting on profiles. \mathcal{S}_R is non-linear ($\mathcal{S}_R[\mu h] \neq \mu \mathcal{S}_R[h]$) and implies partial loss of information. Interestingly, for tip shapes $g_R = f_R^{[\gamma]}$, we can still derive a scaling relation for $\mathcal{S}_R[h]$. Writing Eq. (5) for a profile scaled according to Eq. (4) yields

$$\begin{aligned} \mathcal{S}_R[\mu h] &= \max_{x'} \left(\mu h(x') - \frac{|x - x'|^\gamma}{2R^{\gamma-1}} \right) \\ \mathcal{S}_R[\mu h] &= \mu \left\{ \max_{x'} \left(h(x') - \frac{|x - x'|^\gamma}{2(\mu^{1/(\gamma-1)}R)^{\gamma-1}} \right) \right\} \\ \mathcal{S}_R[\mu h] &= \mu \mathcal{S}_{R'}[h] \quad \text{with} \quad R' = \mu^{1/(\gamma-1)}R. \end{aligned} \quad (6)$$

This relationship states that the bias induced by scanning a profile with a given tip-radius is equivalent to that obtained by scanning the vertically expanded profile with a thinner tip. Now, we turn to the investigation of the influence of the local probe size on the height-height correlation function. Qualitatively, applying \mathcal{S} dampens the roughness details at length scales smaller than a characteristic length Δx_c . Let us consider two nearby points x_1 and x_2 close enough to a point x_0 such that $\tilde{h}(x_{1,2}) = h(x_0) - f_R^{[\gamma]}(x_{1,2} - x_0)$, as depicted in Fig. 1. Setting $x_2 = x_1 + \Delta x$, for values of Δx much smaller than Δx_c , we get $\tilde{h}(x_2) - \tilde{h}(x_1) = f_R^{[\gamma]}(x_1 - x_0 + \Delta x) - f_R^{[\gamma]}(x_1 - x_0) \sim \frac{df_R^{[\gamma]}}{dx}(x_1 - x_0)\Delta x$. The root mean square of this quantity, $\Delta \tilde{h}$, scales like Δx , with a prefactor that we conjecture to be proportional to $\frac{df_R^{[\gamma]}}{dx}(\Delta x_c)$. On the other hand, the very large scale structure of the profile is not affected, and we expect $\Delta \tilde{h} \sim \Delta x^\zeta$ for $\Delta x \gg \Delta x_c$. We can now evaluate how Δx_c scales with R , ζ , and l by assuming that at Δx_c , the height of the tip equates the height-height

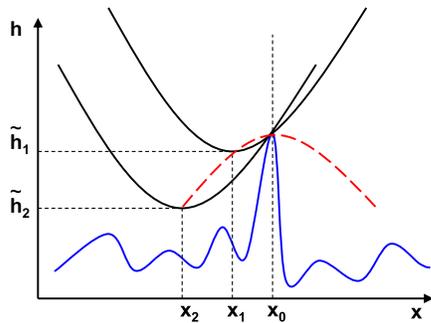


FIG. 1 (color online). Schematic of the small scale behavior of the smoothed profile. For two closeby points, the probe (parabolas) touches a unique distant peak on the profile. We have drawn the corresponding portion of the measured profile \tilde{h} (dotted line)

correlation:

$$f_R^{[\gamma]}(\Delta x_c) \sim \Delta h(\Delta x_c). \quad (7)$$

Using Eq. (3) and the expression for the chosen tip shape yields

$$\frac{\Delta x_c^\gamma}{2R^{\gamma-1}} \sim \Delta x_c^\zeta l^{1-\zeta}. \quad (8)$$

Solving for Δx_c and dropping the numerical prefactor gives the approximate scaling relation

$$\Delta x_c \sim (R^{\gamma-1} l^{1-\zeta})^{1/(\gamma-\zeta)}. \quad (9)$$

In order to assess the validity of this relation, we have performed numerical simulations of self-affine profiles with exponents ζ ranging from 0.2 to 0.9 and scaled the topothesy l in the range $10^{-3}l_0$ to 10^3l_0 according to Eq. (4). Parabolic shapes are reported in the literature for pristine tips [23]. This shape also provides a well-defined radius of curvature, and is expected to describe accurately the close vicinity of the apex for a smooth convex tip from Taylor's expansion. We hence focus on the parabolic case $\gamma = 2$ with tip radius of curvature R ranging from $10^{-5}l_0$ to 10^3l_0 , where l_0 is the spatial sampling interval. In the following, we will drop l_0 in our notations, and consider all length scales in units l_0 . The self-affine profiles have been obtained using the spectral method described in [24]; they contain 20 000 data points each. For all values of these parameters, we compute the height-height correlation function for the original and the smoothed profiles. An example is shown in the main panel of Fig. 2. The self-affine exponent and topothesy of the simulated profiles are evaluated according to the following method. We define the function Λ by

$$\Lambda(\Delta x, \eta) = \left(\frac{\Delta h}{\Delta x^\eta} \right)^{1/(1-\eta)}. \quad (10)$$

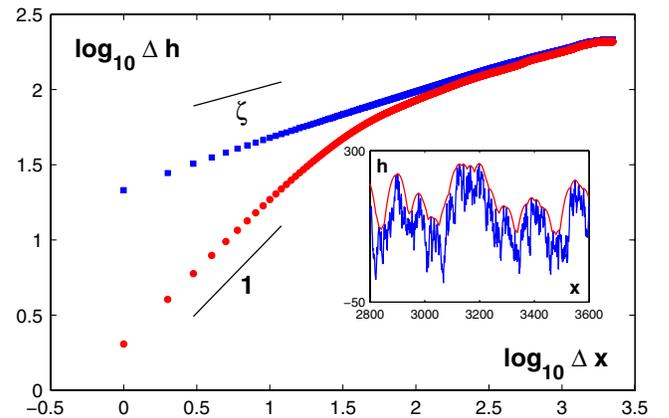


FIG. 2 (color online). *Main panel:* Height-height correlation function evaluated for (i) a self-affine profile with $\zeta = 0.33$ and $l = 100$ (■), (ii) the same profile smoothed with a tip of size $R = 7.8$ (●). *Inset:* Portion of the corresponding original (rough line) and smoothed (line) profiles.

It follows from Eq. (3) that $\Lambda(\Delta x, \zeta) = l$ for all Δx . We evaluate $\Lambda(\Delta X, \eta)$ for a uniform random variable ΔX . ζ is then defined as the value for which the variance of Λ reaches a minimum in η , and the average value of $\Lambda(\Delta X, \zeta)$ provides an estimator of l based on its fundamental invariance property $\Delta h(l) = l$.

We observe a clear crossover between the small and large scale behavior of $\Delta \tilde{h}$. At large scales, $\Delta \tilde{h}$ asymptotically behaves like Δh . It has to be noted that it reaches this regime very slowly, and even though the exponent reaches ζ from above, $\Delta \tilde{h}$ remains underneath the original correlation function, resulting in underestimation of the surface roughness amplitude and overestimation of the exponent. At scales smaller than the crossover length scale Δx_c , $\Delta \tilde{h}$ bends down and reaches the expected linear scaling after a long transient. In order to extract the position of the cutoff Δx_c , we extract the local behavior of $\Delta \tilde{h}$ around $\Delta x = l_0$ by fitting a line

$$\log_{10} \Delta \tilde{h} = \alpha(R, \zeta, l) \log_{10} \Delta x + \beta(R, \zeta, l) \quad (11)$$

through the first two points of $\Delta \tilde{h}$: α is essentially the log derivative of \tilde{h} at the resolution l_0 (i.e., at the smallest accessible value of Δx). We have represented in Fig. 3 (Top) the behavior of α and β as a function of the tip radius R for $\zeta = 0.33$ and $l = 100$. Two regimes are clearly observed. For values of R smaller than a cutoff $R_0(\zeta, l)$, the height-height correlation function is not affected by the smoothing effect. From Eq. (3), we get that in this regime, $\alpha(R, \zeta, l) = \zeta$ and $\beta(R, \zeta, l) = (1 - \zeta) \log_{10} l$ when $R < R_0(\zeta, l)$. For values of R much larger than R_0 , α converges towards 1, as expected, whereas β essentially behaves like a power law in R .

In order to extract the scaling of the threshold R_0 , we fit $\beta = a(\zeta, l) \log_{10} R + b(\zeta, l)$. The function $a(\zeta, l)$ appears to depend only marginally on l , which we neglect.

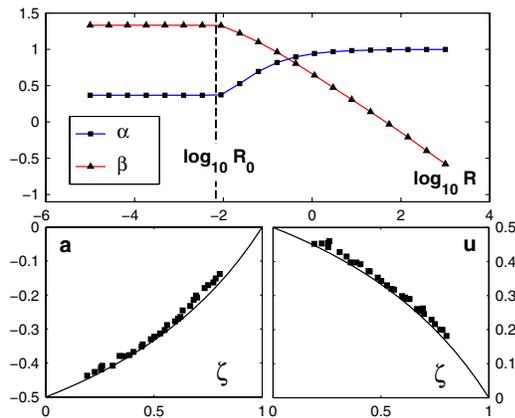


FIG. 3 (color online). *Top*: Apparent parameters α and β as a function of $\log_{10} R$ for $\zeta = 0.33$ and $l = 100$. *Bottom left*: Parameter a as a function of exponent ζ . The line represents $-\frac{1-\zeta}{2-\zeta}$. *Bottom right*: Parameter u as a function of exponent ζ . The line represents $\frac{1-\zeta}{2-\zeta}$.

The dependence of a on ζ is depicted in Fig. 3 (Bottom left). It can be accurately modeled by $a = -\frac{1-\zeta}{2-\zeta}$. We now turn to the scaling of b , which is well described by $b = u \log_{10} l + v$. No significant dependence on ζ is found for v , and this number is of the order of -0.1 , which is negligible and will be dropped henceforth. We find $u = \frac{1-\zeta}{2-\zeta}$, as shown in Fig. 3 (Bottom right). Altogether, the behavior of β conveniently writes

$$\beta = \left(\frac{1-\zeta}{2-\zeta} \right) \log_{10} \frac{l}{R} \quad \text{when } R \gg R_0. \quad (12)$$

We can now extract R_0 by intersecting the small and large scale behaviors of β , which reads, in units l_0

$$(1 - \zeta) \log_{10} l = \left(\frac{1-\zeta}{2-\zeta} \right) \log_{10} \frac{l}{R_0}. \quad (13)$$

This yields

$$\log_{10} R_0 = (\zeta - 1) \log_{10} l. \quad (14)$$

It is interesting to notice that since $\zeta - 1$ is smaller than 1, the effect of the tip appears for smaller radii when the topography is larger. This scaling is a consequence of the equivalence expressed in Eq. (6). The existence of this cutoff is an effect of the resolution l_0 of our measurement. As a matter of fact, restoring the sampling length scale yields $\Delta x_c(R_0) = l_0$. This means that for radii smaller than R_0 , the cutoff length Δx_c becomes smaller than the resolution and hence disappears from the resolved portion of the correlation function. In the asymptotic regime where $R \gg R_0$, the small scale exponent α goes to 1, as can be seen in Fig. 3 (Top). Thus, the asymptotic form of the correlation function for $R \gg R_0$, or equivalently $\Delta x_c \gg \Delta x$, reads

$$\log_{10} \Delta \tilde{h} = \log_{10} \Delta x + \frac{1-\zeta}{2-\zeta} \log_{10} \frac{l}{R}. \quad (15)$$

Solving $\Delta \tilde{h}(\Delta x_c) = \Delta h(\Delta x_c)$ yields Eq. (9) derived above for the expression of Δx_c .

This result confirms our asymptotic conjecture in the parabolic case since

$$\log_{10} \frac{df_R^{[2]}}{dx}(\Delta x_c) = \log_{10} \frac{\Delta x_c}{R} = \beta. \quad (16)$$

To check the relevance of this analysis, we have performed AFM (Veeco Nanoscope Dimension V) measurements on fused silica glass (Corning 7980) fracture surfaces. We break a DCDC sample in the stress-corrosion regime, in conditions detailed in [8]. Then, we scan the topography of the fracture surface with the AFM in tapping mode ($2 \times 2 \mu\text{m}^2$, 512×512 pixels). The height-height correlation function of the data parallel to the crack front is shown in Fig. 4. Two scaling regimes are observed: a 0.8 exponent at small scales, and a 0.2 exponent at large scales. Once this is done, we acquire an image of the tip of the

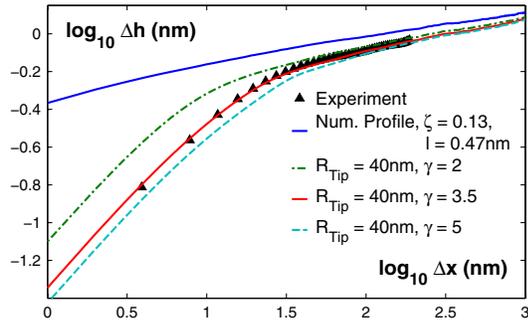


FIG. 4 (color online). Experimental height-height correlation functions obtained for a silica glass fracture surface scanned with an AFM with tip radius $R = 40$ nm. Original and smoothed height-height correlation functions obtained for a numerical profile with $\zeta = 0.13$ and a 40 nm tip for different values of γ .

AFM with a silicon tip characterizing grating (TGT01, NT-MDT, Russia). By fitting $f_R^{[\gamma]}$ on this measurement, we evaluate $R_{\text{Tip}} = 40 \pm 5$ nm and a shape parameter $\gamma = 4 \pm 0.5$, which is typical for AFM tips on hard substrates.

Then, through trial and error, we select a numerical profile with $\zeta = 0.13$, which is close to the classical logarithmic behavior [18]. We smooth it using the measured value of R_{Tip} , and different values of γ . The resulting correlation functions for this value of ζ , superimposed to the experimental ones in Fig. 4, reproduce quantitatively our measurements for $\gamma = 3.5$, which is compatible with the measured shape of the tip.

Altogether, these results strongly suggest that the small scale self-affine regime with a large exponent and the associated cutoff we observe on silica glass fracture surfaces are due to the tip-smoothing effect. We conjecture that earlier measurements using contact probes on different materials might exhibit such bias. The numerical procedure we proposed provides a sharp metrological constraint on roughness characterization and allows for accuracy checks on earlier results. Further work is needed to understand the slow convergence of the correlation function at large scales, to reconstruct the statistical properties of the original roughness from a smoothed profile, and to understand the full 2D case in the presence of anisotropy.

To conclude, we have shown that the use of a finite-size contact probe to scan a self-affine surface significantly affects its measured small scale roughness properties. In particular, we have derived theoretically and checked numerically the dependence of the length scale at which this effect starts on the surface parameters and the asymptotic small scale behavior of the height-height correlation function. Finally, we have performed experiments confirming the relevance of this analysis regarding AFM metrology and provided insight into the origin of previously reported large Hurst exponents at small scales.

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